

ES20 COMPACT SAMPLING SYSTEM (20 barg) 145 psig

The ES20 Compact Sampling System is designed to reliable and accurately measure dew point, or moisture content in a wide variety of industrial gas applications.

Product Parent Code: ES20-M/ES20-I Compact Sampling System (metric units/imperial units) for use with dew-point transmitters Product Ordering Code {Feature A}+{Feature B}+{Feature C}+{Feature D}+{Feature E}+{Feature F}+{Feature M}				
Feature {A}	Base Model			
	ES20 - M	Base unit (Metric units: 6 mm fittings & tubing)		
	ES20 - I	Base unit (Imperial units: 1/4 inch fittings & tubing)		
Feature {B}	Filter			
	B1	Particulate filter (99.5% removal of 0.1 µm particulates)		
	B2	Coalescing filter with drain (99.5% removal of 0.1 µm particulates & aerosols)		
Feature {C}	Enclosure			
	C1	No enclosure		
	C2	GRP enclosure with window (IP66 / NEMA 4X)		
	C3	SS enclosure with window (IP66 / NEMA 4X)		
Feature {D}	Pressure			
	D1	Dew point measurement at process or atmospheric pressure (>= 0.2barg inlet pressure required)		
	D2*	Sub-atmospheric <0.2barg pressure with pump fitted (230 V AC)		
	D3*	Sub-atmospheric <0.2barg pressure with pump fitted (110 V AC)		
Feature {E}	Plate			
	E1	SS plate no bracket		
	E2	SS plate with bracket for monitor		
Feature {F}	Options			
	F1**	Transmitter and monitor fitted		
	F2***	Transmitter only fitted, no monitor		
Feature {M}	Material Certification			
	M1	No certificate		
	M2	Material certification to BS EN 10204 – type 3.1		
	•	* Feature D2 or D3 can only be included with feature B1		
** Feature F1 can only be included with feature E2				
		*** Feature F2 can only be included with feature E1		

Ordering Example

ES20-M + B1 + C2 + D1 + E2 + F1+M1	ES20 compact sampling system (metric units) for system pressure dew point 20 barg (290 psig), particulates filter, mounted on SS plate with mounting bracket for monitor, GRP enclosure with window and no material certification
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ES20 COMPACT SAMPLING SYSTEM ACCESSORIES AND SPARE PARTS

Order Codes	Product / Description
SSF-PF-10PK	Pack of 10 particulate filter cartridges (for protection against fine particulates < 0.1µm (for Sampler Kits))
SSF-CF-10PK	Pack of 10 particulates filter cartridges (for protection against fine particulates & aerosols < 0.1µm (for Sampler Kits))
CCM-03	Cooling/venting coil (3m of 6mm tube for cooling sample gas or preventing back diffusion of ambient moisture)
CCI-03	Cooling/venting coil (3m of 1/4" tube for cooling sample gas or preventing back diffusion of ambient moisture)



ES20 EASIDEW PRO XP SAMPLING SYSTEM

The ES20 Easidew PRO XP Sampling System is designed to reliable and accurately measure dew point, or moisture content in a wide variety of industrial gas applications.

Product Parent Code: ES20-XP-M/ES20-XP-I Sampling System (metric units/imperial units) for use with explosion proof dew-point transmitters					
Product Ordering Code {Feature A}+{Feature B}+{Feature C}+{Feature D}+{Feature E}+{Feature F}+{Feature M}					
Feature	Item	Description			
Feature {A}	Base Model				
	ES20-XP-M	Metric units (tube & fittings 6mm)			
	ES20-XP-I	Base unit (Imperial units: 1/4 inch fittings & tubing)			
Feature {B}	Filter				
	B1	Particulate filter (99.5% removal of 0.1 μm particulates)			
	B2	Coalescing filter with drain (99.5% removal of 0.1 µm particulates & aerosols)			
Feature {C}	Enclosure				
	C1	No enclosure			
	C2	GRP enclosure with window (IP66 / NEMA 4X)			
	C3	SS enclosure with window (IP66 / NEMA 4X)			
Feature {D}	Pressure				
	D1	Dew point measurement at process or atmospheric pressure (>= 0.2barg inlet pressure required)			
Feature {E}	Plate				
	E1	SS plate no bracket			
Feature {F}	Options				
	F1	Transmitter with display EX2			
	F2	Transmitter, no display EX1			
Feature {M}	Material Certification				
	M1	No certificate			
	M2	Material certification to BS EN 10204 – type 3.1			

Ordering Example

	ES20 Easidew PRO XP sampling system (metric units) for system pressure dew point 20 barg (290 psig), particulates filter. mounted on SS plate. GRP enclosure with window and no material certification
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ES20 EASIDEW PRO XP SAMPLING SYSTEM ACCESSORIES AND SPARE PARTS

Order Codes	Product / Description
SSF-PF-10PK	Pack of 10 particulate filter cartridges (for protection against fine particulates < 0.1µm (for Sampler Kits))
SSF-CF-10PK	Pack of 10 particulates filter cartridges (for protection against fine particulates & aerosols < 0.1µm (for Sampler Kits))

Please note: Michell Instruments adopts a continuous development program which sometimes necessitates specification changes without notice. Please contact us for latest version. Issue No: ES20 Sampling System order codes_97448_V4_UK_1119